

**Search Notes**

Application/Control No.

10/813,932

Examiner

John J. Park

Applicant(s)/Patent under  
Reexamination

SCHROER, DAN J.

Art Unit

2876

**SEARCHED**

Class	Subclass	Date	Examiner
235	380		
235	382		
235	375		
235	379		
235	487		
700	2		
283	75	2/10/2005	JP

**INTERFERENCE SEARCHED**

Class	Subclass	Date	Examiner

**SEARCH NOTES  
(INCLUDING SEARCH STRATEGY)**

	DATE	EXMR
EAST		
Text Search		
Consulted with S. Paik in AU 2876	2/10/2005	JP